

Docket No.: 59516-052



*John*

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

|                                   |   |                           |
|-----------------------------------|---|---------------------------|
| In re Application of              | : | Customer Number: 20277    |
| Zi-Kui LIU, et al.                | : | Confirmation Number: 1022 |
| Application No.: 10/784,899       | : | Group Art Unit: 1775      |
| Filed: February 24, 2004          | : | Examiner: to be assigned  |
| For: BORIDE THIN FILMS ON SILICON | : |                           |

**PRELIMINARY AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please amend the application as follows.

**BEST AVAILABLE COPY**